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OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)									
	O. KITAKAMI, et al. "Low-Temperature Ordering of L1 ₀ -CoPt Thin Films Promoted by Sn, Pb, Sb, and Bi Additives",								
148	AW	APPLIED PHYSICS LETTERS, VOLUME 78, NUMBER 8, February 19, 2001, pgs. 1104-1106							
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	AZ	Additional References sheet(s) attached							
Examiner					Date Consi			14.4.7	
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									